



10/609,157

**In the United States Patent and Trademark Office**

~~Serial~~ Serial Number: NA

10/609, 157

Appn. Filed: 06/30/2003 (by retunned receiving postcard)

Applicant: Hai Jiang

## Appn. Title: FABRICATION OF ULTRA-SMALL MEMORY ELEMENTS

Mailed: 09/16/2003  
At: Fremont, CA 94539

## Information Disclosure Statement

Commissioner for Patent  
Washington, DC 20231

Sir:

Attached is a completed Forms PTO/SB/08(A&B) and copies of the pertinent parts of the references cited thereon.

Very respectfully,

Applicant: H. J. Dyer

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Date: 2003, Sept. 16.

Hai Jiang, Applicant      Hai Jiang



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INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

of

Attorney Docket Number

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## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	F	J. N. Zhou, etc, "Thickness dependence of magnetic percolation threshold in as-deposited	
		and annealed Fe-SiO <sub>2</sub> granular very thin films", J. Appl. Phys. 84, (1998)5693	
	G	S. Lai, etc, ""OUM - a 180 nm non-volatile memory cell element technology for stand	
		alone and embedded applications", <a href="http://www.intel.com/research/silicon/flash.htm">http://www.intel.com/research/silicon/flash.htm</a>	

Examiner Signature	Date Considered
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PTO/SB/08A (04-03)

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## **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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Sheet 1 of 2

**Complete if Known**

Application Number	
Filing Date	06-30-2003
First Named Inventor	Hai Jiang
Art Unit	
Examiner Name	
Attorney Docket Number	

**U. S. PATENT DOCUMENTS**

## FOREIGN PATENT DOCUMENTS

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